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SERIAL NUMBER 10/656,312	FILING DATE 09/05/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. TI-22398.1
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APPLICANTS
 Sylvia H. Pas, Plano, TX;

** CONTINUING DATA *****
 This application is a DIV of 09/758,610 01/11/2001 PAT 6,780,250

** FOREIGN APPLICATIONS ***** "None"

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 12/13/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	<input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>[Signature]</i> Initials <i>SA</i>	STATE OR COUNTRY TX	SHEETS DRAWING 2	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
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ADDRESS
 23494
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TITLE
 System and method for integrated oxide removal and processing of a semiconductor wafer

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